Opto-Edu (Beijing) Co., Ltd.

Opto Edu A62.4501 Scanning Microscope Curve Basic Level Atomic Force

Basic Information

Place of Origin: China
Brand Name: OPTO-EDU
Certification: CE, Rohs
Model Number: A62.4501
Minimum Order Quantity: 1pc

Price: FOB \$1~1000, Depend on Order Quantity
 Packaging Details: Carton Packing, For Export Transportation

• Delivery Time: 5~20 Days

Payment Terms:
 L/C, T/T, Western Union

Supply Ability: 5000 pcs/ Month



Product Specification

• Work Mode: "Contact Mode Tapping Mode Optional

Friction Mode Phase Mode Magnetic Mode

Electrostatic Mode"

• Current Spectrum Curve: "RMS-Z Curve F-Z Force Curve"

XY Scan Range: 20×20um
XY Scan Resolution: 0.2nm
Z Scan Range: 2.5um
Y Scan Resolution: 0.05nm
Scan Speed: 0.6Hz~30Hz
Scan Angle: 0~360°

• Sample Size: "Φ≤90mm H≤20mm"

• Shock-Absorbing Design: "Spring Suspension Metal Shielding Box"

• Optical Syestem: "4x Objective Resolution 2.5um"

Output: USB2.0/3.0
 Software: Win XP/7/8/10

Basic Level Atomic Force Microscope

Basic Level, Separate controller & main body design, with Contact Mode, Tapping Mode, 4x Objective

The scanning probe and the sample stage are integrated, and the anti-interference ability is strong

- 2. Precision laser and probe positioning device, it is simple and convenient to replace the probe and adjust the spot;
- 4X objective lens optical positioning, no need to focus, real-time observation and positioning of the probe sample scanning area

The spring suspension shockproof method is simple and practical, and has strong anti-interference ability



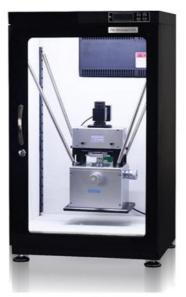
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A62.4501

Basic Level Atomic Force Microscope (AFM)





Product Details

- The laser detection head and the sample scanning stage are integrated, the structure is very stable, and the anti-interference is strong
- ◆ Precision probe positioning device, laser spot alignment adjustment is very easy
- The single-axis drive sample automatically approaches the probe vertically, so that the needle tip is perpendicular to the sample scan
- The intelligent needle feeding method of motor-controlled pressurized piezoelectric ceramic automatic detection protects the probe and the sample
- Automatic optical positioning, no need to focus, real-time observation and positioning of the probe sample scanning area
- ◆ Spring suspension shockproof method, simple and practical, good shockproof effect
- Metal shielded soundproof box, built-in high-precision temperature and humidity sensor, real-time monitoring of the working environment
- Integrated scanner nonlinear correction user editor, nanometer characterization and measurement accuracy better than 98%

Application Case









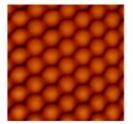
High-order graphite/scanning range 5nm×5nm



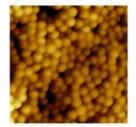
Gold clusters/scanning range 0.5µm×0.5µm



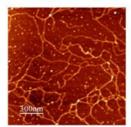
Polysaccharide 10x10um



Polystyrene ball 10x10um

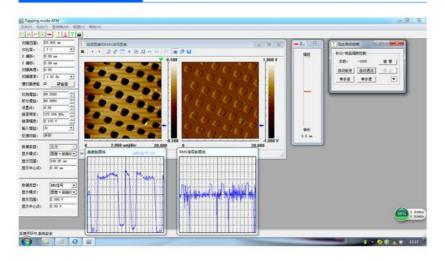


Polystyrene ball 5x5um



Polysaccharide 1.5x1.5um

Product Details





Specification







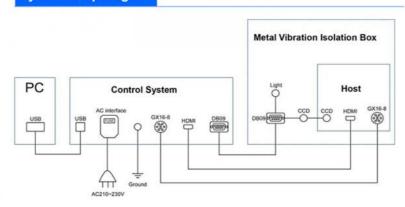






| | | Tapping | Mode | Contact Mode | | Contact Mode | 1 | act Mode | | |
|--------------------------|---------------------|----------------------------------|-------------|----------------------------------|---------------------|---------------------------|---------------------|--|--------------------------|--|
| Work Mode | | | | Tapping Mode | | Tapping Mode | Тарр | Tapping Mode | | |
| | | Optional Contact Mode | | Optional | | Ontional | Onti | anal | | |
| | | Friction | | Optional Friction Mode | | Optional Friction Mode | | Optional Friction Mode | | |
| | | Phase N | | Phase Mode | | | | Phase Mode | | |
| | | Magnetic Mode | | Magnetic Mode | | Magnetic Mode | | | | |
| | | Electrostatic Mode | | Electrostatic Mo | de | Electrostatic Mode E | | Electrostatic Mode | | |
| | | RMS-Z | Curve | | | | | | | |
| Current Spe | ctrum | | | RMS-Z Curve | | RMS-Z Curve | RMS-Z Curve | | | |
| Curve | | Optional | | F-Z Force Curve | | F-Z Force Curve | F-Z F | F-Z Force Curve | | |
| VV Coo - D - | | F-Z Force Curve | | 00.00 | | | | 50×50um | | |
| 3- | | 20×20um | | 20×20um | | 50×50um | 50×5 | oum | | |
| XY Scan Resolution | | 0.2nm | | 0.2nm | | 0.2nm | 0.2nm | | | |
| Z Scan Range | | 2.5um | | 2.5um | | 5um | 5um | | | |
| ŭ | | 0.05nm | | 0.05nm | | 0.05nm | 0.05nm | | | |
| | | 0.6Hz~3 | RNHz | 0.6Hz~30Hz | | | | 0.6Hz~30Hz | | |
| · · | | 0.0112°C | JUI 12 | 0~360° | | | | 0~360° | | |
| Scan Angle | | 0~360° Φ≤90mm | | 0~360° Ф<90mm | | | | 90mm | | |
| Sample Size | | Ψ≤90mm H≤20mm | | Ψ≤90mm H≤20mm | | Ψ≤90mm H≤20mm | | | Omm | |
| XY Stage Moving | | 15×15mm | | 15×15mm | | | | ×25um | | |
| Shock-Absorbing | | - | | Spring Suspension | | Spring Suspension | | | | |
| Design S | | Spring S | Suspension | Metal Shielding Box | | Metal Shielding E | - | - | | |
| | | + | | | | <u> </u> | | Eyepiece 10x | | |
| | | | | | | | Infini | Infinity Plan LWD APO 5x10x20x50x | | |
| Optical Syestem | | 4x Objective Resolution 2.5um | | 4x Objective Resolution 2.5um | | 10x Objective | 5.0M | 5.0M Digital Camera 10" LCD Monitor, With Measuring | | |
| | | | | | | Resolution 1um | | | | |
| | | | | | | | | LED Kohler Illumination Coaxial Coarse & Fine Focusing | | |
| | | | | | | LICDO O/O O | | USB2.0/3.0 | | |
| | | | | USB2.0/3.0 | | USB2.0/3.0 | | 2.0/3.0 XP/7/8/10 | | |
| Software | | Win XP | 7/8/10 | Win XP/7/8/10 | | Win XP/7/8/10 | vvin | XP/7/8/10 | | |
| Microscope | | | Optical Mic | roscope | Electron Microscope | | | Scanning Probe Microscope | | |
| Max Resolution (um) | | 1) | 0.18 | 0.0 | | 00011 | | 0.00008 | | |
| | | | Oil immersi | on 15000x I | | aging diamond ca | rbon | Imaging high-order graphitic carbon atoms | | |
| Remark | | | | | | | | | | |
| Probe-Sample Interaction | | | | Measure Signal | | | Informat | Information | | |
| | | | | Electrostatic Force | | | Shape | | | |
| Tunnel Current | | | | Current | | | Shape, Conductivity | | | |
| ŭ | | | | Phase | | | Magnetic Structure | | | |
| Electrostatic Force | | | | Phase | | | charge distribution | | | |
| Resolution Wor | | | Workir | king Condition Worki | | ing Temperation | Damge to | amge to Sample Inspection Depth | | |
| SPM | Atom Level 0.1nm I | | m I | ,, | | n or Low peration | None | | 1~2 Atom Level | |
| TEM I | Point 0.3~0.5nm | | High V | | | n Temperation | Small | Small Usually < | | |
| SEM (| | | High V | High Vaccum | | Room Temperation | | | 10mm @10x 1um @10000x | |
| FIM | Atom Level 0.1nm Su | | m Super | Super High Vaccum | | 0K | Damge | | Atom Thickness | |
| | | | | | | | | | | |

System Diaphragm



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